TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. SEC.1151			
In Re Application Of: Sun-Lee HWANG et al.						
Serial No.	Filing Date	Examiner	Group Art Unit			
NEW	MARCH 22, 2004	TO BE ASSIGNED	TO BE ASSIGNED			
Title: METHOD OF ALIGNING A SEMICONDUCTOR SUBSTRATE WITH A SEMICONDUCTOR ALIGNMENT APPARATUS						
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450						
	37 C	FR 1.97(b)				
1. A The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.						
 The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of: 						
☐ the statement specified in 37 CFR 1.97(e);						
OR						
☐ the fee se	et forth in 37 CFR 1.17(p).					

	OSURE STATEMENT 7(c))	Docket No. SEC.1151		
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NEW MARCH 22, 2004		TO BE ASSIGNED	TO BE ASSIGNED	
METHOD OF AL	IGNING A SEMICONDUCTOR	SUBSTRATE WITH A SEMICONI	DUCTOR	
APPARATUS				
		ment of Fee ects to pay the fee set forth in 37 CFR 1.1	7(0))	
☐ A check in the amount of is attached. ☐ The Director is hereby authorized to charge and credit Deposit Account No. ☐ as described below. ☐ Charge the amount of ☐ Credit any overpayment. ☐ Charge any additional fee required. ☐ Certificate of Transmission by Facsimile* ☐ Certificate of Transmission by Facsimile* ☐ Certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F: ☐ (Date) ☐ (Date) ☐ A check in the amount of is attached. ☐ Certify Deposit Account No. ☐ Charge the amount of ☐ Charge the amount of ☐ Charge the amount of ☐ Credit any overpayment. ☐ Certificate of Mailing by First Class Mail ☐ I certify that this document and fee is being deposited on with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.				
Signature Signature of Perso			Mailing Correspondence	
Typed or Printed N	Typed or Printed Name of Person	f Person Mailing Certificate		
		Dated: MARCH 22, 2004		

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number
SEC.1151	NEW
Applicant(s) Sun-Lee HWANG et al.	
Filing Date	Group Art Unit
MARCH 22, 2004	TO BE ASSIGNED

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				U.S. PATENT DOCUMENTS				
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	A	4,780,288	10/25/1988	AUGHWANE			n manus	
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				FOREIGN PATENT DOCUMENTS				
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
				OTHER DOCUMENTS (Including .	Author, Title, Da	ıte, Pertinent Pa	ges, Etc.)	
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EXAMINE	R			DATE CONSIDERED				
EXAMINE!	R: Initi	al if citation considered, whether o	or not citation is in	conformance with MPEP Section 609; Dapplicant.)raw line throug	h citation if not	in conforms	ance and